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**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: A8700

Lawrence SHAH, et al.

Appln. No.: 10/813,269

Group Art Unit: 2828

Confirmation No.: 5356

Examiner: Dung T. NGUYEN

Filed: March 31, 2004

For: FEMTOSECOND LASER PROCESSING SYSTEM WITH PROCESS PARAMETERS  
CONTROLS AND FEEDBACK

**RESPONSE TO RESTRICTION REQUIREMENT**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 24, 2006, please consider the remarks as  
submitted herewith on the accompanying pages.